



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of: **IRINO, Kiyoshi**

Serial No.: 09/428,052

Filed: October 27, 1999

Group Art Unit: 2815

#22

Ext. 1 ms

**Examiner: Jose R. Diaz**

P.T.O. Confirmation No.: 4139

12/27/02

**For. SEMICONDUCTOR MEMORY DEVICE CONTAINING NITROGEN IN A GATE OXIDE FILM**

## **PETITION FOR EXTENSION OF TIME**

Commissioner for Patents  
Washington, D.C. 20231

Date: December 13, 2002

Sir:

Applicants petition the Commissioner for Patents to extend the time for response to the Office Action dated August 14, 2002 for one month from November 14, 2002 to December 14, 2002.

Attached please find a check in the amount of \$110.00 to cover the cost of the extension for a large entity. In the event that any additional fees are due in connection with this paper, please charge our Deposit Account No. 01-2340. Two copies of this paper are enclosed herewith.

Respectfully submitted,

**ARMSTRONG, WESTERMAN & HATTORI, LLP**

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SGA/arf

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